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By:

LINDA E. HASTINGS

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#16/B
9/18/02
10/16/02
Muller

ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE
Serial No.: 09/614,286
Filed: July 12, 2000
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner: Timothy J. Sutton
Group Art Unit: 2813

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
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TECHNOLOGY CENTER 2800

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed on May 30, 2002, the period for
responding thereto expiring after August 30, 2002, please amend the subject application
as follows: